

APPLICATION INFORMATION

Application Type::	REGULAR
Subject Matter::	UTILITY
CD-ROM or CD-R?::	NONE
Title::	METHOD, DEVICE AND DIFFRACTION GRATING FOR SEPARATING SEMICONDUCTOR ELEMENTS FORMED ON A SUBSTRATE BY ALTERING SAID DIFFRACTION GRATING
Attorney Docket Number::	292853US2PCT
Total Drawing Sheets::	3

INVENTOR INFORMATION

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	The Netherlands
Status::	FULL CAPACITY
Given Name::	Hendrikus
Middle Name::	Petrus
Family Name::	VAN DER LAAK
City of Residence::	TL Beuningen
Country of Residence::	The Netherlands
Street of Mailing Address::	Platinawerf 20g
City of Mailing Address::	TL Beuningen
Country of Mailing Address::	The Netherlands
Postal or Zip Code of Mailing Address::	NL-6641

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	The Netherlands
Status::	FULL CAPACITY
Given Name::	Hans
Middle Name::	Peter
Family Name::	CHALL
City of Residence::	TL Beuningen
Country of Residence::	The Netherlands
Street of Mailing Address::	Platinawerf 20g
City of Mailing Address::	TL Beuningen
Country of Mailing Address::	The Netherlands
Postal or Zip Code of Mailing Address::	NL-6641

## CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

## DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/NL04/00922	12/29/04

## FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
03079210.5	Europe	12/30/03	YES

## ASSIGNMENT INFORMATION

Assignee Name:: Advanced Laser Separation International  
B.V.  
Street of Mailing Address:: Platinawerf 20G  
City of Mailing Address:: TL Beuningen  
Country of Mailing Address:: The Netherlands  
Postal or Zip Code of Mailing Address:: NL-6641